


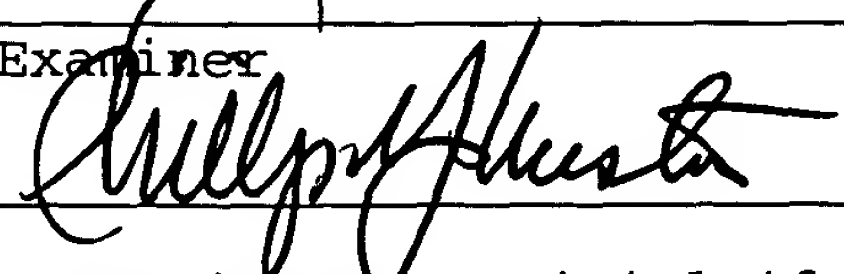
INFORMATION DISCLOSURE CITATION	Atty. Docket No.		Serial No.	
	3180.0278		09/817,270	
	Applicant			
	Inanami et al.			
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	March 27, 2001		Unknown	



U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date

FOREIGN PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Country	Class	Sub-Class	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
J	Inanami et al., "Throughput Enhancement Strategy of Maskless Electron Beam Direct Writing for Logic Device," IEDM 2000 Technical Digest (Sept. 22, 2000)

Examiner	Date Considered
	12/10/02

\* Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.